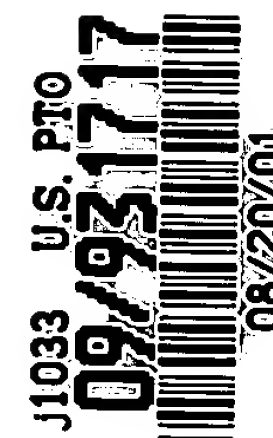


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Docket: 740756-2350



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Hideaki NINOMIYA et al.)
Japanese Priority No. 2000-290558) Attn: Applications
Japanese Priority Date: September 25, 2000) Branch
For: METHOD OF SUPPORTING A FLEXIBLE)
SUBSTRATE AND METHOD OF MANUFAC-)
TURING A SEMICONDUCTOR DEVICE) Date: August 20, 2001

INFORMATION DISCLOSURE STATEMENT

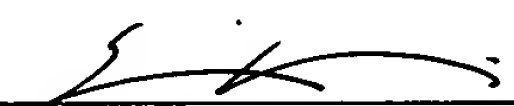
Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

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